L Number	Hits	Search Text	DB	Time stamp
1	2	"20040023447"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/06 12:44
2	120	organic adj TFT	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/06 12:45
3	71	(organic adj TFT) and solution	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/06 12:45
4	48	((organic adj TFT) and solution) and inject$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/06 13:13
5	1		USPAT	2004/07/06 13:01
6	1		USPAT	2004/07/06 13:02
7	1		USPAT	2004/07/06 13:03
8	1		USPAT	2004/07/06 13:05
9	21252	organic adj solution	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/06 13:14
10	8690	(organic adj solution) and inject$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/06 13:14
11	277319	257/$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/06 13:15
12	41247	thin adj film adj transistor	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/06 13:15
13	46	((organic adj solution) and inject$4) and (thin adj film adj transistor)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/06 13:49
14	153142	438/$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/06 13:49
15	35	((organic adj solution) and inject$4) and 438/$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/06 13:49

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- (2) "20040023447"
- (120) organic adj TFT
- (71) (organic adj TFT) and solution
- (48) ((organic adj TFT) and solution) and inject$4
- (1) "6635508".PN.
- (1) "6344662".PN.
- (1) "5892244".PN.
- (1) "5705826".PN.
- (21252) organic adj solution
- (8690) (organic adj solution) and inject$4
- (277319) 257/$.ccls.
- (41247) thin adj film adj transistor
- (46) ((organic adj solution) and inject$4) and (thin adj film adj transistor)
- (153142) 438/$.ccls.
- (35) ((organic adj solution) and inject$4) and 438/$.ccls.

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((organic adj solution) and inject$4) and 438/$.ccls.

7/6/04 TTN

	U	I	Document ID	Issue Date	Pages	Title	Current OR	Current XRef	Retrieval Cla	Inventor	S	C	P			Image I
1			US 20040115847 A1	20040617	33	Method for fabricating semiconductor light emitting device	438/22			Hasegawa, Yoshiaki et al.	☑					US 2004
2			US 20040097014 A1	20040520	32	SEMICONDUCTOR PACKAGE WITH A DIE ATTACH ADHESIVE	438/118			Musa, Osama M.	☑					US 2004
3			US 20040038459 A1	20040226	16	Field effect transistors and materials and methods for their manufacture	438/142			Brown, Beverley Anne et al.	☑					US 2004
4	☑		US 20030114002 A1	20030619	14	Methods and apparatus for patterning a surface	438/689			Hubbell, Jeffrey A. et al.						US 2003
5	☑		US 20030087533 A1	20030508	17	Liquid crystal-templated conducting organic polymers	438/745			Stupp, Samuel I. et al.						US 2003
6	☑		US 20030060038 A1	20030327	40	Forming interconnects	438/637	257/E21.255; 257/E21.582;		Sirringhaus, Henning et al.						US 2003
7	☑		US 20030059987 A1	20030327	40	Inkjet-fabricated integrated circuits	438/149	257/E21.255; 257/E21.582;		Sirringhaus, Henning et al.						US 2003
8	☑		US 20030059984 A1	20030327	40	Solution processing	438/141	216/2; 216/63;		Sirringhaus, Henning et al.						US 2003
9			US 20030059975 A1	20030327	43	Solution processed devices	438/99	257/40; 257/E21.255;		Sirringhaus, Henning et al.	☑					US 2003
10			US 20020187657 A1	20021212	20	Semiconductor device and method for manufacturing the same	438/789	257/E21.169; 257/E21.576;		Morozumi, Yukio	☑					US 2002
11			US 20020142621 A1	20021003	10	VAPOR PHASE DEPOSITION OF UNIFORM AND ULTRATHIN SIL...	438/765			WANG, YUCHUNG	☑					US 2002
12			US 20010051403 A1	20011213	7	Method and apparatus for deposition of porous silica dielectrics	438/202	257/E21.273		Miller, Gayle W. et al.	☑					US 2001
13			US 20010019858 A1	20010906	15	Semiconductor device and method of manufacturing the same	438/149	257/E29.275		Hiroki, Masamitsu et al.	☑					US 2001
14			US 20010008298 A1	20010719	42	Semiconductor device and method of manufacturing same	257/578	257/566; 257/E21.608;		Sato, Fumihiko	☑					US 2001
15			US 6743667 B2	20040601	16	Method of manufacturing an active matrix type device	438/166			Hiroki, Masamitsu et al.	☑					US 6743

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